



JFW/2812

**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q85504

Heiji WATANABE, et al.

Appln. No.: 10/519,084

Group Art Unit: 2812

Confirmation No.: 7332

Examiner: Not Yet Assigned

Filed: December 23, 2004

For: SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF

**SUPPLEMENTAL PRELIMINARY AMENDMENT**

**MAIL STOP NON-FEE AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Prior to examination, please amend the above-identified application as follows on the accompanying pages.

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